

Electronic Information Disclosure Statement



DRYING PROCESS FOR LOW-K DIELECTRIC FILMS

Application:

10/065861

Confirmation: 3384

Applicant(s): Carlo Waldfried

Docket

ATI-0016

Number:

Group Art

Unit:

1746

Examiner:

A. MARKOFF

(4341592 or 4885047 or 5498308 or 6203582 or 6235453 or 6238161 or 6281135 or 6328809 or

search string: 20010010950 or 20010048867 or 20010030101 or 20010051082 or 20020033136 or 20010037822 or 20020037655).pn.

RECEIVED
JAN 16 2003
TECHNOLOGY CENTER 1700

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
<i>RA</i>	P01	4341592	1982-07-27		Shortes, et al.		
	P02	4885047	1989-12-05		Ury, et al.		
	P03	5498308	1996-03-12		Kamarehi, et al.		
	P04	6203582	2001-03-20		Berner, et al.		
	P05	6235453	2001-05-22		You, et al.		
<i>RA</i>	P06	6238161	2001-05-29		Kirkpatrick, et al.		

A. MARKOFF 12/12/04

<i>AM</i>	P07	6281135	2001-08-28		Han, et al.
<i>AM</i>	P08	6328809	2001-12-11		Elsawy, et al.

Published Applications

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
<i>AM</i>	U01	20010010950	2001-08-02		Savage, et al.		
	U02	20010048867	2001-12-06		Lebar, et al.		
	U03	20010030101	2001-10-18		Berner, et al.		
	U04	20010051082	2001-12-13		Kirkpatrick, et al.		
	U05	20020033136	2002-03-21		Savage, et al.		
	U06	20010037822	2001-11-08		Elsawy, et al.		
<i>AM</i>	U07	20020037655	2002-03-28		Hasunuma, et al.		

Signature

Examiner Name	Date
<i>A. MARUOL</i>	<i>12/12/04</i>

